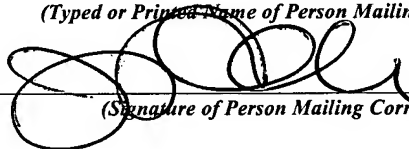


1765

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)		Docket No.	
Applicant(s): GEUN-YOUNG YEOM		HNE-0001	
Serial No. 10/010,548	Filing Date 11/08/2001	Examiner	Group Art Unit
Invention: METHOD OF ETCHING SEMICONDUCTOR DEVICE USING NEUTRAL BEAM AND APPARATUS FOR ETCHING THE SAME			
<div>RECEIVED AUG 07 2003 TC 1700</div>			
<p>I hereby certify that this <u>Response to Restriction Requirement w/ Amendment/Pursuant to 37 CFR Section 1.111</u> (Identify type of correspondence)</p> <p>is being deposited with the United States Postal Service as first class mail in an envelope addressed to:</p> <p>Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on <u>July 28, 2003</u> (Date)</p> <p><u>Jennifer Matson</u> (Typed or Printed Name of Person Mailing Correspondence)</p> <p> (Signature of Person Mailing Correspondence)</p>			
<p>Note: Each paper must have its own certificate of mailing.</p>			